

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Priority Application Serial No. 09/518,511
Priority Filing Date March 3, 2000
Inventor Dinesh Chopra
Assignee Micron Technology, Inc.
Priority Group Art Unit 2825
Priority Examiner L. Malsawma
Attorney's Docket No. MI22-2345
Title: Conductive Connection Forming Methods, Oxidation Reducing Methods, and Integrated
Circuits Formed Thereby

INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 C.F.R. §§ 1.56, 1.97 AND 1.98

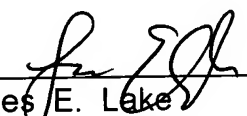
In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

The listed references were cited by, or submitted to, the Office in the parent, co-pending application of the above-identified application. The above-identified application is a continuation application of co-pending application Serial No. 09/518,511, filed March 3, 2000. Such prior disclosure is sufficient for the above-identified application as far as copies of the references are concerned. 37 C.F.R. § 1.98(d) and MPEP § 609(2).

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: 15 July 2003



James E. Lake
Reg. No. 44,854

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-2345		Priority SERIAL NO. 09/518,511	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Dinesh Chopra			
				Priority FILING DATE March 3, 2000		Priority GROUP 2825	
U.S. PATENT DOCUMENTS							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	4,393,096	7/83	Gajda			
	AB	5,071,714	12/91	Rodbell et al			
	AC	5,565,378	10/96	Harada et al			
	AD	5,656,860	8/97	Lee			
	AE	6,030,895	2/00	Joshi et al			
	AF	6,110,819	8/00	Colgan et al			
	AG	6,110,829	8/00	Besser et al			
	AH	6,140,236	10/00	Restaino et al			
	AI	6,146,988	11/00	Ngo et al			
	AJ	6,147,000	11/00	You et al			
	AK	6,171,960 B1	1/01	Lee			
	AL	6,174,810 B1	1/01	Islam et al			
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
							Yes No
	AM	JP 404280979A	10/92	Japan			
	AN						
	AO						
	AP						
	AQ						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
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U.S. PATENT DOCUMENTS							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	6,214,731 B1	4/01	Nogami et al			
	AB	6,147,000	11/00	You et al			
	AC	6,107,687	08/00	Fukada et al			
	AD	5,592,024	01/97	Aoyama et al			
	AE	5,455,195	10/95	Ramsey et al			
	AF	5,518,936	5/96	Yamamoto et al			
	AG	6,261,939	7/01	Skalal et al			
	AH	6,261,950	7/01	Tobben et al			
	AI	6,306,750	10/01	Huang et al			
	AJ	6,329,722	12/01	Shih et al			
	AK	6,358,849	03/02	Havemann et al			
	AL	6,323,131	11/01	Obeng et al			

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*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	5,898,222	4/99	Farooq et al			
	AB	5,360,995	11/94	Graas			
	AC	5,378,660	01/95	Ngan et al			
	AD	5,547,881	08/96	Wang et al			
	AE	5,656,546	08/97	Chen			
	AF	5,851,922	12/98	Bevk et al			
	AG	5,885,896	03/99	Thakur et al			
	AH	6,468,906	10/02	Chan et al			
	AI	3,826,886	07/74	Hara et al			
	AJ	3,839,727	10/74	Herdzik et al			
	AK	3,839,780	10/74	Freedman et al			
	AL	3,887,994	06/75	Ku et al			

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	AA	4,319,967	03/82	Vratny et al			
	AB	4,565,586	01/86	Church et al			
	AC	4,698,233	10/87	Ohira et al			
	AD	5,096,508	03/92	Breedis et al			
	AE	5,258,329	11/93	Shibata			
	AF	5,272,015	12/93	Hamdi et al			
	AG	5,296,653	03/94	Kiyota et al			
	AH	5,390,141	02/95	Cohen et al			
	AI	5,788,830	08/98	Sakamoto et al			
	AJ	6,100,195	08/00	Chan et al			
	AK	6,171,949	01/01	You et al			
	AL	6,174,812	01/01	Hsiung et al			
	AM	6,644,567	09/02	Besser et al			
	AN	6,468,906	10/02	Chan et al			
	AO	6,495,200	12/02	Chan et al			
	AP						

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